



DOCKET NO: 245557US0SX

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :
MASANOBU OGINO, ET AL. : EXAMINER: NGUYEN, T. T.
SERIAL NO: 10/713,054 :
FILED: NOVEMBER 17, 2003 : GROUP ART UNIT: 2813
FOR: SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURE
THEREOF:

REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated October 30, 2006, reconsideration is requested
in view of the following remarks:

Remarks begin on page 2 of this response.